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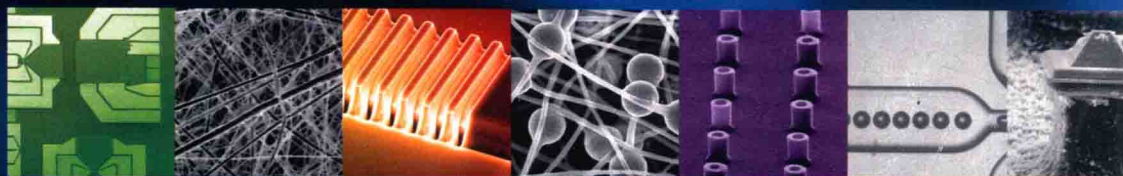


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Conference & Expo 2011

Technical Proceedings | **Vol. 2**

Electronics, Devices, Fabrication, MEMS, Fluidics and Computational



Nanotechnology 2011: Electronics, Devices, Fabrication, MEMS, Fluidics and Computational

Technical Proceedings of the 2011 NSTI Nanotechnology
Conference and Expo

NSTI-Nanotech 2011, Vol. 2

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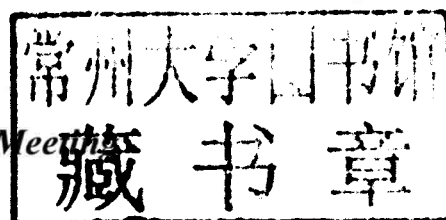
*An Interdisciplinary Integrative Forum on
Nanotechnology, Biotechnology and Microtechnology*

June 13-16, 2011

Boston, Massachusetts, U.S.A.

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The 14th annual NSTI Nanotechnology Conference and Expo is part of the TechConnect World Annual Conference & Expo which includes the parallel sister events of: TechConnect Summit 2011, Clean Technology 2011, Microtech 2011, Bio Nanotech 2011, and the 10th Workshop of Compact Modeling 2011. The combined interdisciplinary conferences focus on moving emerging applied technologies from research to market to society.

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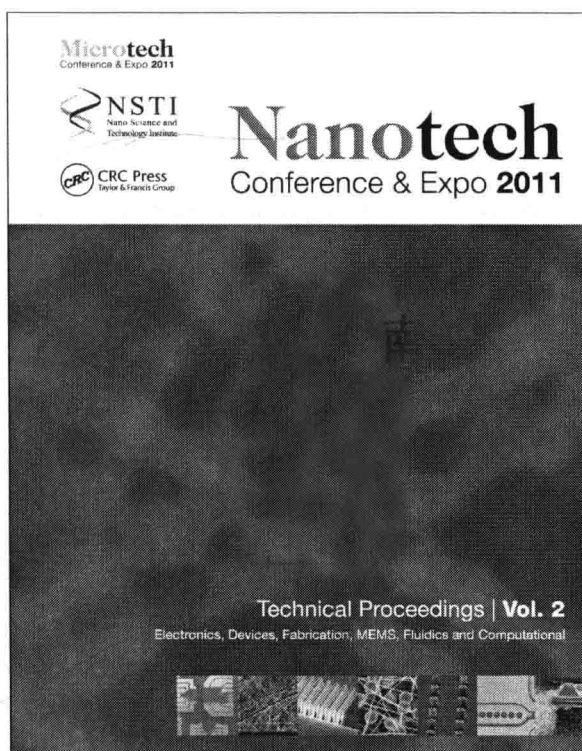
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